

Notice of References Cited	Application/Control No. 10/825,110		Applicant(s)/Patent Under Reexamination CHEN, MEI-LI	
	Examiner John Rivell		Art Unit 3753	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-4,784,180 A	11-1988	Sieberhagen, Gunter	137/625.4
*	C	US-5,141,153 A	08-1992	Jeffress, Ronald E.	236/93B
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	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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